
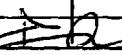
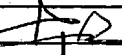


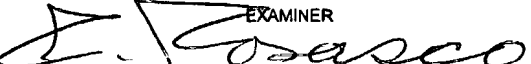


INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 55071-280		SERIAL NO. C ntinuati n of Appl. N . 09/840,291	
				APPLICANT Jang Fung CHEN, et al.			
				FILING DATE September 16, 2003		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code(s) (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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		EP 1 122 603	08/08/01		Yes	No	
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			EP 0 620 498	10/19/94			
			JP-11223930	08/17/1999			
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		Fourmun Lee and Tom Zirkle, "Process for Hybrid Phase-Shifting Mask Fabrication," 03/01/93, pages 1-2.					
EXAMINER 				DATE CONSIDERED 3/11/04			

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